

SEP 27 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/810,387
Confirmation No. 8779
Filing Date March 15, 2001
Inventor Craig M. Carpenter
Assignee Micron Technology, Inc.
Group Art Unit 1763
Examiner R. Zervigon
Attorney's Docket No. MI22-1559
Customer No. 021567
Title: Chemical Vapor Deposition Apparatuses and Deposition Methods

**PRELIMINARY AMENDMENT TO ACCOMPANY RCE FILING AND RESPONSE TO
MAY 27, 2004 OFFICE ACTION**

To: MS RCE
Commissioner for Patents
PO Box 1450
Art Unit 1763
Alexandria, VA 22313

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AMENDMENTS